



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re U.S. Patent Application of: ) Attorney Docket: 4425-167

KUO ET AL.

) Group Art Unit: 2876

Serial No.: 09/916, 270

) Examiner: STEVEN S. PAIK

Filed: JULY 30, 2001

For: **SYSTEM AND METHOD FOR INTERLOCKING MANAGEMENT  
IN SEMICONDUCTOR MATERIAL SUPPLY EQUIPMENT**

MAR 20 2003  
TC 2800 MAIL ROOM

*S/a*  
*J. Mailey*  
*3-22-03*

**AMENDMENT**

Honorable Commissioner for Patent  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed December 18, 2002, to which a response is due without extension by March 18, 2003, please amend the above-identified patent application as follows.

In the Claims:

Please amend Claims 1 through 5, 7 through 9, 13 through 17, 19, 20, 21, and 25.

1.(Amended) Apparatus for interlocking material supply equipment in semiconductor manufacture system, said apparatus comprising:

a wireless controller used for treatment of bar-code information;

a bar-code scanner communicating with said wireless controller through a transmission system, said bar-code scanner for collecting said bar-code information of said material supply equipment; and